Electronic Patent Application Fee Transmittal								
Application Number:	1079	10798331						
Filing Date:	12-A	12-Mar-2004						
Title of Invention:	Method for manufacturing sputter-coated substrates, magnetron source and sputtering chamber with such source							
First Named Inventor/Applicant Name:	Stan	Stanislav Kadlec						
Filer:	Ronald J. Shore/Krista Hargrove							
Attorney Docket Number:	635.	635.43483X00						
Filed as Large Entity								
Utility under 35 USC 111(a) Filing Fees								
Description		Fee Code	Quantity	Amount	Sub-Total in USD(\$)			
Basic Filing:								
Pages:								
Claims:								
Miscellaneous-Filing:								
Petition:								
Patent-Appeals-and-Interference:								
Post-Allowance-and-Post-Issuance:								
Extension-of-Time:								

Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
Miscellaneous:				
Request for continued examination	1801	1	810	810
	Total in USD (\$)			810